

AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Original) A millimetre or sub-millimetre wave illumination system comprising:
at least one primary radiation source adapted to emit radiation at one or more wavelengths of interest in at least one radiation field state;
a baffle comprising a non transmissive surface and having positioned therein a plurality of transmissive exit apertures;
a surface reflective at millimetre or sub-millimetre wavelengths for inducing a plurality of radiation paths between the source and the baffle;
characterised in that the system further incorporates means for generating a plurality of radiation field states in a pre-determined time interval.
2. (Original) An illumination system as claimed in claim 1 wherein the means for generating the radiation field state or states is arranged to change the radiation field state or states within a time shorter than a basic integration period of an associated imaging system.
3. (Currently Amended) An illumination system as claimed in claim 1 ~~or claim 2~~ wherein the baffle and the reflective surface form a part of a container, and the at least one source is arranged to emit radiation into the container.

4. (Currently Amended) An illumination system as claimed in ~~any of claims 1 to 3~~
wherein the means for changing the radiation field state or states includes a mechanical
actuator attached such that it is capable of moving the reflective surface.

5. (Currently Amended) An illumination system as claimed in ~~any of claims 1 to 3~~
wherein the means for changing the radiation field state or states incorporates a
moveable structure for disturbing an electromagnetic field between the source and the
baffle.

6. (Original) An illumination system as claimed in claim 5 wherein the moveable
structure comprises a reflective material.

7. (Original) An illumination system as claimed in claim 5 wherein the moveable
structure comprises an absorptive material.

8. (Currently Amended) An illumination system as claimed in claim ~~8~~5 wherein the
moveable structure comprises a dielectric material.

9. (Currently Amended) An illumination system as claimed in ~~any of claims 1 to 3~~
wherein the means for changing the radiation field state or states comprises means for
changing the effective point at which the primary source provides an output of radiation
towards the baffle and the reflective surface.

10. (Original) An illumination system as claimed in claim 9 wherein the means for changing the effective point at which the primary source provides an output of radiation comprises a primary source output adapted to be moveable with respect to the reflecting surface and the baffle.

11. (Original) An illumination system as claimed in claim 9 wherein the means for changing the effective point at which the primary source provides an output of radiation comprises a switch arranged to switch radiation from the primary source to one of a plurality of spatially separate outputs.

12. (Original) A method of generating millimetre or sub-millimetre wave illumination comprising the steps of:

feeding millimetre or sub-millimetre wave radiation from at least one primary source towards a reflecting surface and a baffle, the baffle comprising a non transmissive surface and having positioned therein a plurality of transmissive exit apertures, such that the reflecting surface induces a plurality of radiation paths between the source and the baffle;

generating a plurality of radiation field states between the source and the exit apertures over a pre-determined time interval.

13. (New) A millimetre or sub-millimetre wave illumination system comprising:
at least one primary radiation source adapted to emit radiation at one or more wavelengths of interest in at least one radiation field state;

a baffle comprising a non transmissive surface and having positioned therein a plurality of transmissive exit apertures;

a surface reflective at millimetre or sub-millimetre wavelengths for inducing a plurality of radiation paths between the source and the baffle;

characterised in that the system further incorporates a generator for generating a plurality of radiation field states in a pre-determined time interval.